

INTERNATIONAL STANDARD

NORME INTERNATIONALE

Semiconductor devices – Hot carrier test on MOS transistors

Dispositifs à semiconducteurs – Essai de porteur chaud sur les transistors MOS



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INTERNATIONAL ELECTROTECHNICAL COMMISSION

**SEMICONDUCTOR DEVICES –
HOT CARRIER TEST ON MOS TRANSISTORS**
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47/2041/FDIS	47/2048/RVD

Full information on the voting for the approval of this standard can be found in the report on voting indicated in the above table.

This publication has been drafted in accordance with the ISO/IEC Directives, Part 2.

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SEMICONDUCTOR DEVICES – HOT CARRIER TEST ON MOS TRANSISTORS

1 Scope

This standard describes the wafer level hot carrier test on NMOS and PMOS transistors. The test is intended to determine whether the single transistors in a certain (C)MOS process meet the required hot carrier lifetime.

2 Abbreviations and letter symbols

In this document the following abbreviations and letter symbols apply:

MOS	Metal Oxide Semiconductor
NMOS	n-channel MOS transistor
PMOS	p-channel MOS transistor
(C)MOS	Complementary MOS
L [μm]	length of polysilicon gate of MOS transistor
W [μm]	width of polysilicon gate of MOS transistor
L_{nominal} [μm]	minimum L allowed by the design rules of the process
W_{nominal} [μm]	minimum W allowed by the design rules of the process
V_{gs} [V]	gate-source voltage of MOS transistor
V_{ds} [V]	drain-source voltage of MOS transistor
V_{bs} [V]	backgate-source voltage of MOS transistor
I_{ds} [μA]:	drain-source current of MOS transistor
I_{b} [μA]	substrate current of MOS transistor
I_{g} [nA]	gate current of MOS transistor
$V_{\text{gs, stress}}$ [V]	V_{gs} biasing condition during hot carrier stress
$V_{\text{ds, stress}}$ [V]	V_{ds} biasing condition during hot carrier stress
$V_{\text{ds, use_max}}$ [V]	maximum V_{ds} allowed by the design rules of the process as stated in the design manual
$V_{\text{ds, breakdown}}$ [V]	V_{ds} at which avalanche or punch-through currents become dominant; defined as V_{ds} at which $I_{\text{ds}} = 1,5 \times (I_{\text{ds}} \text{ at } V_{\text{ds, use_max}})$ while $V_{\text{gs}} = V_{\text{ds, use_max}}$
V_{t} [V]	threshold voltage of MOS transistor defined as V_{gs} voltage at which $I_{\text{ds}} = 0,01 \times W / L$ [μA]. Other (commonly agreed) definitions of V_{t} are also allowed as long as this is clearly reported.
g_{m} [$\mu\text{A/V}$]	transconductance of MOS transistor
$g_{\text{m, max}}$ [$\mu\text{A/V}$]	maximum transconductance of MOS transistor
$I_{\text{ds, sat}}$ [μA]	saturated drain-source current at $V_{\text{gs}} = V_{\text{ds}} = V_{\text{ds, use_max}}$; $I_{\text{ds, sat_forward}}$ measured with source and drain having same polarity as during stress, $I_{\text{ds, sat_reverse}}$ measured with source and drain polarity interchanged with respect to stress.
L (MOST)	length of the square MOS transistor ($L = W$)
$g_{\text{m, max}}$ (MOST)	$g_{\text{m, max}}$ of the square MOS transistor ($L = W$)